

# Design and Performance of a sub-5 ps jitter Time-to-Digital Converter ASIC in 22 nm CMOS

Si Xie<sup>\*†a,b</sup>, Adam Quinn<sup>\*a</sup>, Artur Apresyan<sup>a</sup>, Davide Braga<sup>a</sup>, Farah Fahim<sup>a</sup>, Sergey Los<sup>a</sup>, Cristián Peña<sup>a</sup>, Carlos Perez<sup>a</sup>, Tom Zimmerman<sup>a</sup>

<sup>a</sup>*Fermi National Accelerator Laboratory, PO Box 500, Batavia IL 60510-5011, USA*  
<sup>b</sup>*California Institute of Technology, Pasadena, CA, USA*

## Abstract

We present the design of a Time-to-Digital Converter (TDC) ASIC together with performance characterization results at cryogenic temperature (6-8 K), and at room temperature using Low-Gain Avalanche Detector (LGAD) signals. The TDC design uses a two-step architecture with a ring-oscillator based counter and a Vernier delay line “fine TDC,” combining low power (0.5 mW) and area (0.003 mm<sup>2</sup>). The TDC is implemented in an FD-SOI process, and back-gate tuning is used both to correct threshold variation due to cryogenic operation and to enable tuning of the fine TDC delay elements with very little overhead. We present test results using the Fermilab Constant Fraction Discriminator (FCFD) ASIC to produce discriminated signals from an internal charge injection mechanism that mimics the waveform and signal amplitude of minimum ionizing particles impinging on LGAD sensors. The TDC ASIC and its associated readout system is used to measure the time-of-arrival of the injected signal relative to an external clock trigger. We characterize the time resolution performance of the full system and verify that the TDC ASIC contributes a negligible amount to the total system time resolution, fully consistent with the expected time resolution contribution of less than 4 ps. The results presented here demonstrate the utility of our TDC for applications in physics and quantum communications.

*Keywords:* Solid state detectors, Timing detectors, Particle tracking detectors (Solid-state detectors), Time-to-digital Converter, TDC, cryo-CMOS, SNSPD, LGAD

<sup>\*</sup>These authors contributed equally to this work.

<sup>†</sup>Corresponding author

*Email address:* [sxie@fnal.gov](mailto:sxie@fnal.gov) (Si Xie<sup>\*†</sup>)

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## **1. Introduction**

2 Precise timing information plays a critical role in many detector systems used for fundamental science  
3 ranging from applications as diverse as single photon detectors for quantum communications [1] to tracking  
4 detectors for future particle colliders [2]. For the former, exploiting and preserving the exquisite temporal  
5 resolution of fast timing detectors such as superconducting nanowire single photon detectors (SNSPDs),  
6 which have demonstrated sub-3 ps resolution [3], requires close integration with high-performance front-end  
7 readout and time-tagging circuits capable of operating at cryogenic temperature (4-20 K) at low power [4].

8 In the field of high energy particle physics, tracking detectors capable of achieving 5-25 ps timing  
9 resolution are necessary for many proposed future particle colliders including the Muon Collider [5], the  
10 FCC-hh [6, 7], and the Electron-Ion Collider (EIC) [8]. Extracting precision timing information from low  
11 gain avalanche detectors (LGAD), which is a leading candidate detector technology for precision timing  
12 tracking detector systems and has been demonstrated to achieve 20-30 ps time resolution [9-13], is an  
13 important representative challenge in particle physics. These future detectors aim to implement sensors  
14 with pixels as small as  $25 \times 25 \mu\text{m}^2$ . While the power of the front-end amplifier for these detectors will  
15 benefit from the significant reduction in input capacitance associated with the increased granularity, the  
16 comparator and the TDC will not, and therefore the contribution to power from TDC will become among  
17 the dominant contributions to the total power budget.

18 As such, the design and implementation of low-power front-end electronics capable of extracting precision  
19 timing information from LGAD sensors represents a key technical milestone. Our two-step time-to-digital-  
20 converter is designed to minimize power and area consumption while providing picosecond resolution. Our  
21 design leverages back-gate biasing in the GlobalFoundries 22FDX silicon-on-insulator node as a novel tuning  
22 mechanism for delay stages, as well as a compensation strategy to enable operation from 4 Kelvin to room  
23 temperature.

24 In this paper, we present the design and performance characterization of our Time-to-Digital Converter  
25 (TDC) ASIC. Its performance is characterized as a function of the delay between the start and stop signals,  
26 and the TDC resolution is measured as a function of the back-gate tuning voltage. Finally, the timing jitter  
27 performance of the TDC is measured using the discriminator output signals from the Fermilab Constant  
28 Fraction Discriminator (FCFD) ASIC, presented in [14], which converts signal pulses into discriminated  
29 waveforms robust against amplitude-induced time-walk, mimicking the output signal of an LGAD detector.

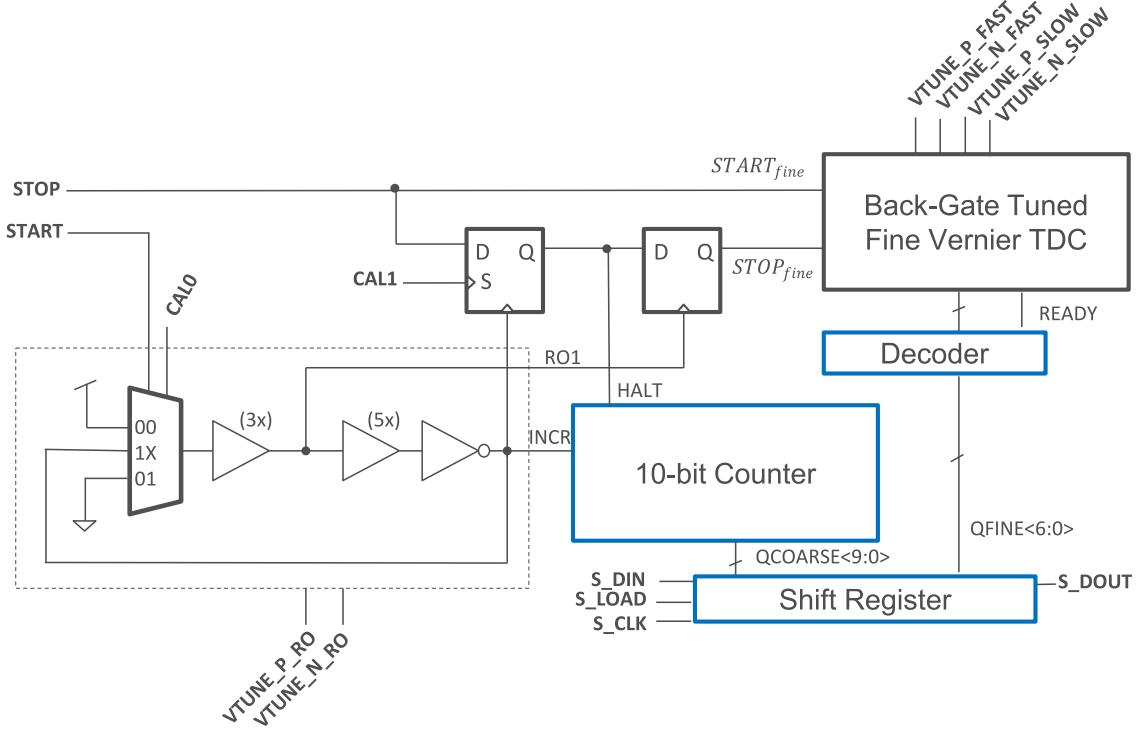


Figure 1: A block diagram of the TDC ASIC design, showing the coarse ring oscillator, DFF interlock, fine Vernier TDC, and serial readout. Bolded signals are inputs or outputs of the test ASIC.

## 2. TDC Design and Readout

The design of precision Time-to-Digital Converters (TDCs) involves a trade-off between figures of merit. Compact, low-power TDCs are highly desirable for quantum communication applications in order to be closely integrated with cryogenic control and readout electronics, as well as for particle tracking applications where a large number of channels must be integrated to disambiguate particle tracks. However, fine time resolution, which implies both a small bin size and low jitter, cannot be sacrificed in either application, and sufficient dynamic range is necessary to allow synchronization with a distributed system reference clock.

The TDC we present is designed with a two-step architecture consisting of a ring-oscillator coarse TDC and a linear Vernier delay line fine TDC. It makes novel use of the back-gate biasing capabilities of the GlobalFoundries 22FDX node to provide fine-tuning for both stages, as well mitigating undesirable effects of cryogenic operation. A single-channel prototype TDC is implemented with simple, low-speed readout capabilities, laying the groundwork for a second ASIC integrating many channels with readout and synchronization logic.

### 2.1. Time-to-Digital Converter Design

A generalized Time-to-Digital Converter produces a digital code which represents the time interval  $T_{in}$  between the rising edges of two signals, generally termed *start* and *stop*. A two-step TDC like the design we present consists of two components: a “coarse” TDC which produces an output digital code  $Q_{coarse}$  such that  $T_{in} \approx T_{lsb(coarse)}Q_{coarse}$ , and a “fine” TDC which measures the error between the coarse prediction and the actual time interval, producing an output  $Q_{fine}$  such that  $T_{in} = T_{lsb(coarse)}Q_{coarse} + T_{lsb(fine)}Q_{fine}$ .

Two-step TDCs can typically outperform single-step TDCs in terms of the combination of dynamic range and resolution, since the circuits which allow a fine TDC to achieve high resolution typically scale poorly

51 for large values of  $T_{in}$ . However, a critical concern for two-step TDCs is the method of coupling signals  
 52 between the two stages, which must not introduce undue jitter or nonlinearity.

53 The two-step architecture of our TDC (see Fig. 1) follows closely from the design reported by Enomoto  
 54 et al. [15], which uses a two-DFF interlock to couple signals between a coarse ring oscillator and a fine  
 55 Vernier TDC. The basic operation of the TDC is as follows:

- 56 1. When the *start* signal arrives, the ring oscillator begins to oscillate, and the coarse TDC begins to  
 57 count.
- 58 2. When the *stop* signal arrives, it immediately asserts the start input to the fine TDC ( $start_{fine}$ ).
- 59 3. On the next assertion of the clock input to DFF1, *HALT* is asserted, and the coarse TDC count is  
 60 frozen.
- 61 4. On the next assertion of the clock input to DFF2, the stop input to the fine TDC is asserted ( $stop_{fine}$ ).  
 62 The fine TDC completes its calculation of the difference between  $start_{fine}$  and  $stop_{fine}$ .

63 The use of two sequential flip-flops ensures that there is always a fixed delay  $T_{gd}$  between the halting  
 64 of the coarse TDC and the assertion of  $stop_{fine}$ . It also suppresses any metastability that results from the  
 65 clock and data inputs of DFF1 changing simultaneously before that metastability can propagate to the fine  
 66 TDC.

67 The relationship between  $T_{in}$  and the TDC digital codes may be derived as follows:

$$T_{in} = T(stop) - T(start) \quad (1)$$

68 Letting  $T(start) = 0$  and noting that the *stop* signal directly triggers  $stop_{fine}$  we have:

$$T_{in} = T(stop_{fine}) \quad (2)$$

$$T_{in} = T(stop_{fine}) - T(start_{fine}) + T(start_{fine}) \quad (3)$$

69 The characteristic equation of the fine TDC is:  $T_{lsb(fine)}Q_{fine} = T(stop_{fine}) - T(start_{fine})$ , which  
 70 yields:

$$T_{in} = T_{lsb(fine)}Q_{fine} + T(start_{fine}) \quad (4)$$

71 Finally, due to the fixed propagation delay from DFF1 through DFF2, we note that:  $T(start_{fine}) =$   
 72  $T_{lsb(coarse)}Q_{coarse} + T_{gd}$ , so we have:

$$T_{in} = T_{lsb(fine)}Q_{fine} + T_{lsb(coarse)}Q_{coarse} + T_{gd} \quad (5)$$

73 The three calibration parameters  $T_{lsb(fine)}$ ,  $T_{lsb(coarse)}$ , and  $T_{gd}$  may be calculated by applying pulses of  
 74 known length to the input of the TDC. After establishing these values,  $T_{in}$  may be calculated from  $Q_{coarse}$   
 75 and  $Q_{fine}$ .

76 It should be noted that some fixed offset  $T_{off}$  is practically present in any TDC due to wire delays and  
 77 fixed mismatches, which must be calibrated for. In our TDC, this is absorbed into  $T_{gd}$ . Thus the use of the  
 78 fixed flip-flop interlock does not introduce a new calibration parameter.

79 The coarse and fine TDC are both constructed of inverter-based delay cells. The coarse TDC is a ring  
 80 oscillator composed of a loop of delay cells whose total delay determines  $T_{lsb(coarse)}$ . The fine TDC is a  
 81 Vernier TDC (Fig. 2), a structure which uses two delay lines with slightly different delays to achieve sub-  
 82 gate-delay timing resolution. The delay per stage of the delay lines attached to *start* and *stop* are  $t_1$  and  $t_2$   
 83 respectively, with  $t_1 > t_2$  such that the rising edge of *stop* eventually catches up to the rising edge of *start*.  
 84 The delay between *start* and *stop* should shrink by  $t_1 - t_2 = T_{lsb(fine)}$ . At each stage, a latch (in the case  
 85 of our TDC, a simple SR latch) compares which signal arrived first. The number of stages after which the  
 86 *start* signal no longer arrives before the *stop* signal yields  $Q_{fine}$ .

87 Our TDC leverages the back-gate bias capabilities of the GlobalFoundries 22FDX fully-depleted silicon-  
 88 on-insulator (FDSOI) process [16] to set the delay of each cell. Six total tuning voltages are exposed: NMOS  
 89 and PMOS back-gate bias voltages for the ring oscillator, and for the slow and fast delay lines of the fine TDC.

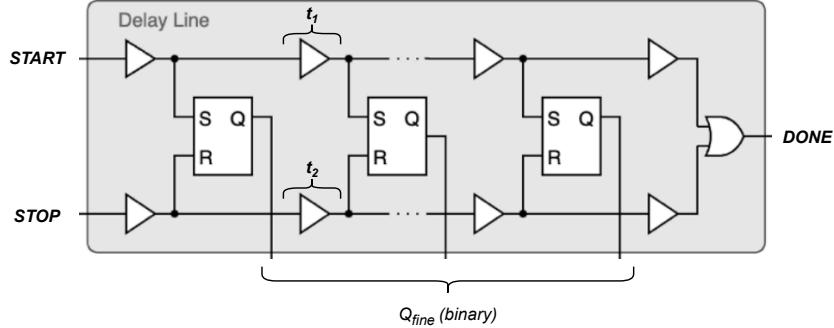


Figure 2: A diagram of a Vernier Delay Line based fine TDC. The TDC is tuned such that  $t_1 - t_2 = T_{lsb(fine)} > 0$

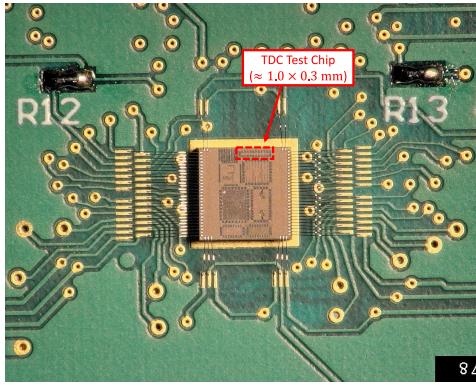


Figure 3: A die photograph of the TDC.

90 This technique dramatically simplifies the design and shrinks layout area by eliminating all of the auxiliary  
 91 circuits which are typically required for delay cell tuning using traditional current-starving or capacitive-  
 92 loading techniques. Crucially, the back-gate bias voltages can be used to forward body-bias transistors  
 93 to negate the characteristic threshold voltage increase observed at cryogenic temperatures [17], and to  
 94 compensate for cryogenic temperature shift, maintaining the same TDC resolution across temperature. The  
 95 design of the fine TDC, in particular, is simplified, as the "fast" and "slow" delay lines are manufactured  
 96 identical to each other: the difference  $\Delta t_2 - \Delta t_1 = T_{lsb(fine)}$  is entirely created by biasing the two delay  
 97 lines at slightly different bias voltages.

### 98 2.2. Test ASIC

99 We implemented, manufactured, and tested a single-channel prototype of this TDC in GlobalFoundries  
 100 22FDX (Fig. 3). The TDC core described above was integrated with simple interfaces and a serial readout  
 101 to enable testing and debugging, which are described in this section. In some cases, these interfaces limit  
 102 the performance of the TDC.

103 A second version of this TDC has also been designed, which is currently under test. This future TDC  
 104 version incorporates thirty-two channels which are synchronized to a shared reference clock using an on-ASIC  
 105 PLL. Additionally, this version uses a sophisticated asynchronous readout architecture which is designed to  
 106 allow all channels to be read out at full rate using 1 Gbps LVDS links.

107 In the test ASIC, all digital signals including *start* and *stop* are 1.8 V non-return-to-zero (NRZ) CMOS  
 108 signals, driven by dedicated I/O cells. In an optimized system, the high-speed interfaces would be co-  
 109 designed with the intended sensor. In the test ASIC, all six TDC core tuning voltages are exposed as

110 I/Os for manual tuning, along with two additional tuning voltages which control the back-gate bias voltage  
 111 applied to digital circuits, primarily for the purpose of compensating for cryogenic threshold voltage shift.  
 112 Finally, the use of a local ring oscillator to drive the coarse TDC is not intended to be scalable due to the  
 113 limits of accumulated jitter and variability between channels; a single-ended ring oscillator like the one in  
 114 this design will also suffer from inherently very limited supply rejection [18], which we did not measure. The  
 115 next version of the TDC will not face this issue due to its on-ASIC PLL.

116 In this prototype ASIC, programming configuration bits and reading out  $Q_{coarse}$  and  $Q_{fine}$  are both  
 117 accomplished using a simple shift register. Each TDC count must be read from the shift register by an  
 118 external controller before another count can be taken, which is the primary limit on readout speed in our  
 119 tests reported below. The TDC architecture is designed to operate at 100 Mcounts/s; it is limited by the  
 120 time taken for the Vernier delay line to converge on a value of  $Q_{coarse}$ .

121 The prototype TDC is implemented as a stand-alone sub-block in a larger 3.0 mm  $\times$  3.0 mm ASIC (Fig.  
 122 3). The block dimensions of 0.3 mm  $\times$  1.0 mm are dominated by the pad ring, while the TDC channel itself  
 123 is 20  $\mu\text{m}$   $\times$  150  $\mu\text{m}$ .

### 124 3. TDC ASIC Characterization

125 We characterize the TDC ASIC by measuring the TDC resolution as a function of the back-gate tuning  
 126 voltage, the TDC jitter as a function of the delay between the start and stop signals ( $T_{in}$ ), and the TDC  
 127 power as a function of the count rate.

#### 128 3.1. Readout

129 In our experiment, a microcontroller (Arduino Portenta) is used for digital control and readout of the  
 130 ASIC, as shown in Figure 4. The microcontroller interfaces with the ASIC through a simple serial interface  
 131 (S\_CLK, S\_DIN, S\_DOUT). In order to prevent shift register action from affecting the internal state of the  
 132 TDC, two additional signals gate the transfer of data between the shift register and the TDC's internal  
 133 shadow registers: S\_PASS is asserted to pass control bits from the shift register into the shadow registers,  
 134 and S\_LOAD is asserted to retrieve data (i.e.  $Q_{coarse}$  and  $Q_{fine}$ ) from the shadow registers and place that  
 135 data in the scan chain.

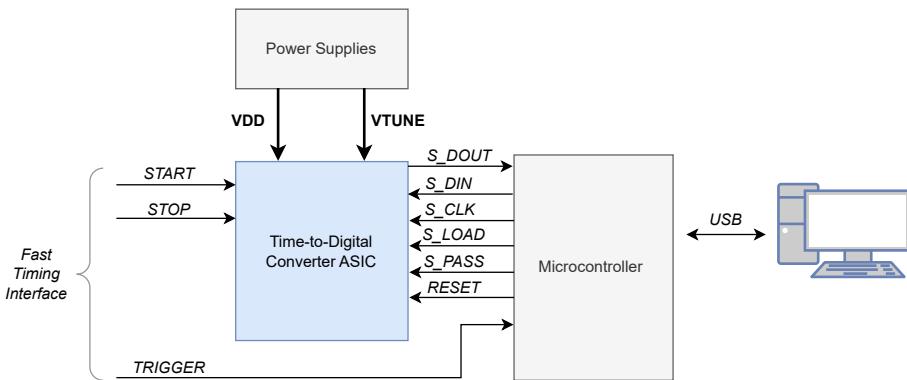


Figure 4: A block diagram illustrating the interfaces between our TDC ASIC and our test setup, including power, digital readout / control, and fast timing interfaces.

136 A trigger signal is supplied directly from the timing source to the microcontroller, which tells the  
 137 microcontroller when to retrieve a new measurement from the ASIC. The precise timing of the trigger signal  
 138 is unimportant:  $Q_{coarse}$  and  $Q_{fine}$  are determined exclusively by  $T_{in} = T(\text{stop}) - T(\text{start})$ . However, one  
 139 trigger pulse must be sent for each START/STOP pair to ensure the microcontroller retrieves the current  
 140 count before it is overwritten by the next count.

141 *3.2. ASIC Characterization*

142 For independent characterization of our TDC we used a Berkley Nucleonics Model 745-OEM Digital  
 143 Delay Generator to supply the START/STOP and trigger signals. The 745-OEM instrument has a delay  
 144 resolution of 1 ps and specified RMS jitter of better than  $T_{j,rms} = 5 \text{ ps} + \text{delay} \times 10^{-8}$ , or approximately 5  
 145 ps for signals in the range of interest. The jitter of our specific instrument was measured to be 3.5 ps using  
 146 a 20 GHz oscilloscope at 2 ns delay.

147 To calibrate the TDC for each test condition, we performed measurements of three fixed input time  
 148 differentials (0ps, 100ps, and 10ns) supplied by the 745-OEM and averaged the TDC response for each over  
 149 a large number of cycles to mitigate jitter. This yielded a system of three equations which can be solved for  
 150 the calibration constants  $T_{lsb(fine)}$ ,  $T_{lsb(coarse)}$ , and  $T_{gd}$  (see Sec 2).

151 *3.3. TDC Resolution vs Tuning Voltage*

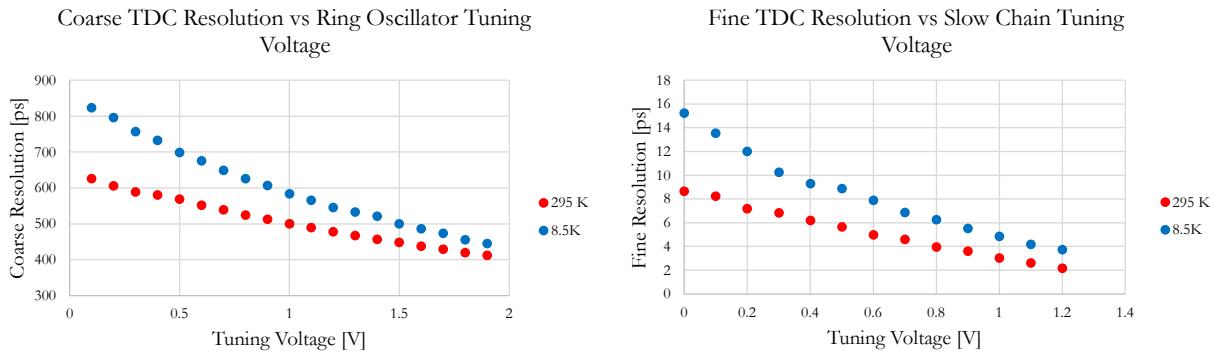


Figure 5: Resolution of the coarse and fine TDCs as a function of back-gate tuning voltage.

152 In order to assess the tunability of the ASIC, we define two tuning parameters  $V_{tune(coarse)}$  and  $V_{tune(fine)}$ .  
 153 The actual tuning voltages for the ASIC are derived from these parameters as shown in Table 1. The  
 154 expressions are defined such that an increase in  $V_{tune(coarse)}$  decreases the coarse TDC resolution, and an  
 155 increase in  $V_{tune(fine)}$  decreases the fine TDC resolution, while keeping NMOS and PMOS drive strengths  
 156 roughly balanced. Nominal values are  $V_{tune(coarse)} = 1V$  and  $V_{tune(fine)} = 0.55V$ .

ASIC Tuning Voltage	Expression from Tuning Parameters
VTUNE_N_RO	$V_{tune(coarse)}$
VTUNE_P_RO	$2 - V_{tune(coarse)}$
VTUNE_N_FAST	1.9 V (fixed)
VTUNE_P_FAST	0.1 V (fixed)
VTUNE_N_SLOW	$V_{tune(fine)}$
VTUNE_P_SLOW	$2 - V_{tune(fine)}$

Table 1: Expressions for ASIC tuning voltages as a function of tuning parameters.

157 To generate each of the two plots in Figure 5 we swept one tuning parameter while keeping the other  
 158 constant. For each tuning voltage value, we took three measurements of known-length pulses and recorded  
 159 the output code from the TDC, then solved this system of three equations as described in 2.1 to find the  
 160 coarse and fine TDC resolution  $t_{R(coarse)}$  and  $t_{R(fine)}$ , which are plotted.

161 When tuning voltage is held constant, we observe that a larger resolution is measured at cryogenic (8.5  
 162 K) temperature versus room temperature. This effect primarily results from the well-known threshold shift  
 163 of CMOS devices at cryogenic temperature [19], which increases the propagation delay of both ring oscillator  
 164 stages and Vernier delay line stages [20]. This effect can be mitigated in some cases by choosing a different  
 165 tuning voltage to compensate for threshold voltage shift. Due to larger overall delays, the tuning slope is  
 166 also approximately twice as large at cryogenic temperatures: we measured 216 ps/V (coarse) and 9.59 ps/V  
 167 (fine) at 8.5K, versus 118 ps/V (coarse) and 5.40 ps/V (fine) at room temperature.

168 *3.4. TDC Jitter*

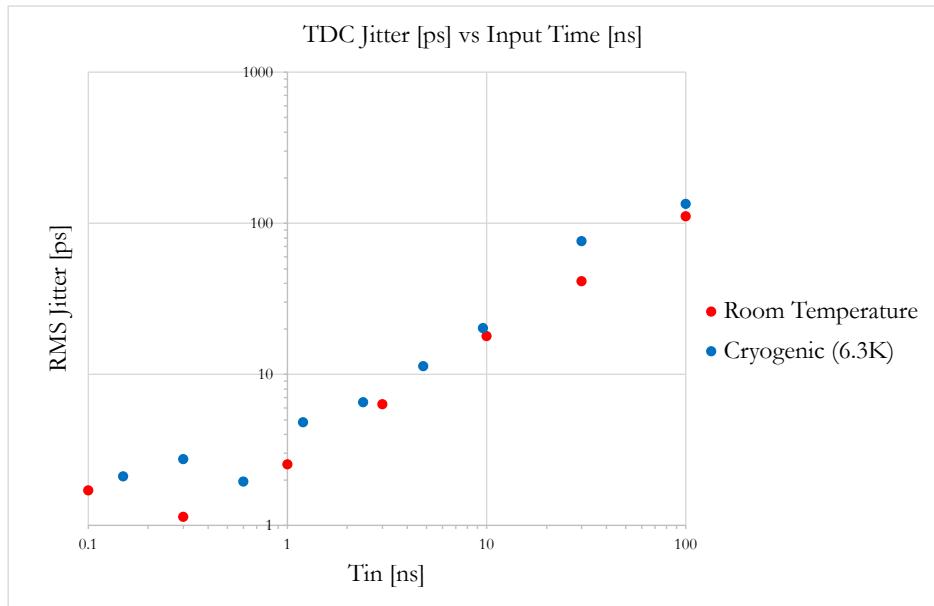


Figure 6: TDC jitter results as a factor of  $T_{in} = T(\text{stop}) - T(\text{start})$ . See note below on temperature.

169 We assessed the jitter of our TDC in isolation by fixing the START/STOP delay ( $T_{in}$ ) and taking a large  
 170 number of samples to build a code distribution. Results as a function of  $T_{in}$  are shown in Fig 6. For small  
 171 values of  $T_{in}$  the jitter of 745-OEM instrument dominates, resulting in an approximately flat jitter value in  
 172 the range of a few picoseconds. For larger values of  $T_{in}$ , accumulated flicker noise around the ring oscillator  
 173 is the dominant noise source, resulting in a roughly linear correlation between jitter and  $T_{in}$ . Future ASICs,  
 174 in which the ring oscillator is replaced by a high-quality PLL, will not exhibit the same jitter accumulation.

175 We measured the performance of the TDC at both room temperature and cryogenic temperature (6.3  
 176 degrees Kelvin). The measurement temperature differs from the previous experiment (8.5K) because different  
 177 instrumentation of our closed-cycle cryostat results in a different heat load and thus a different minimum  
 178 achievable temperature.

179 Because the contribution of thermal noise is already small (<1 ps rms, from simulation) and flicker noise  
 180 is not reduced by low temperature [21], no significant advantage is obtained from cryogenic operation. In  
 181 fact, because the tuning voltage is identical, the cryogenic TDC resolution is slightly larger, resulting in  
 182 slightly higher jitter.

183 *3.5. TDC Power*

184 Our TDC operates in an asynchronous, event-driven fashion, which means that its power consumption  
 185 is highly dependent on the rate of counts, as well as the average time ( $t_{RO}$ ) that the ring oscillator must be  
 186 active in order to resolve each count, which is dependent on the length of START and STOP pulses. For test

187 purposes, we can control the value of  $t_{RO}$  arbitrarily by setting the length of these pulses. Figure 7 illustrates  
 188 power consumption at cryogenic and room temperature up to 1 Mcps, the limit of our test stand, for  $t_{RO}$   
 189 values of 100 and 200 nanoseconds. We observe that both quiescent and dynamic power consumption are  
 190 reduced at cryogenic temperature, due to lower leakage current and slower operation of the TDC at nominal  
 191 tuning levels.

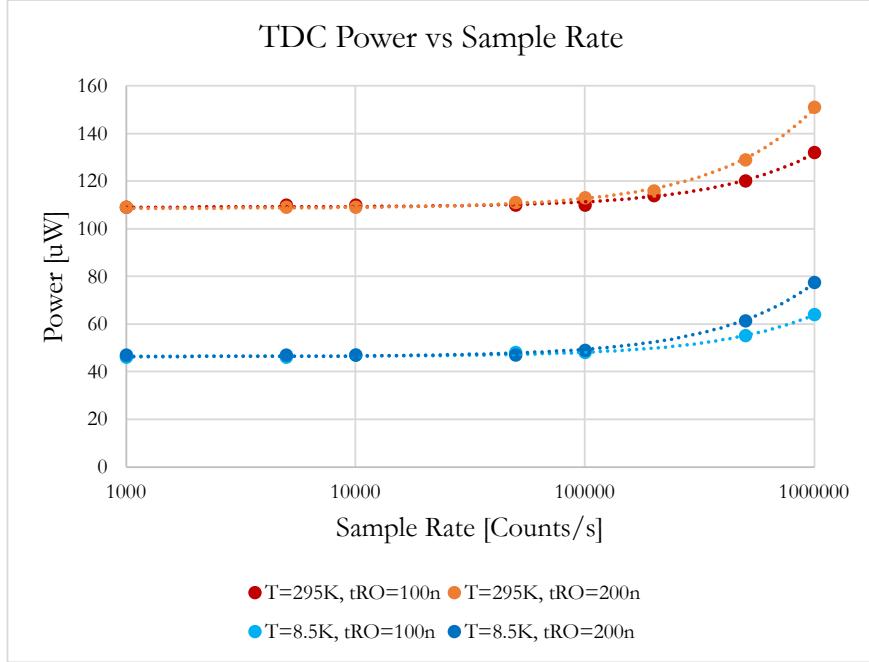


Figure 7: Measured TDC power as a factor of temperature, count rate, and average ring oscillator run time per count ( $t_{RO}$ ) for count rates up to 1 M counts per second, the limit of our test stand.

192 Although our test stand is only capable of driving pulses up to 1 Mcps, the TDC is capable of operating  
 193 with input count rates of at least 100 Mcps. Using the data from Figure 7, we can estimate the breakdown  
 194 of power consumption per block, and use these numbers to estimate power at 100 Mcps as  $P(f_{samp}) =$   
 195  $P_{RO}t_{RO}f_{samp} + E_{fine}f_{samp} + P_{Quiescent}$ . To calculate the power figures of merit in Table 3.5, we assume  
 196  $t_{RO} = 10\text{ns}$ , which means that at an input count rate of 100 Mcps, the ring oscillator is constantly running,  
 197 which is a conservative estimate.

Figure of Merit	295 K	8.5 K
Quiescent Power ( $P_{Quiescent}$ , $\mu\text{W}$ )	109	46.6
Energy per fine ADC Conversion ( $E_{fine}$ , $\text{pJ}$ )	3.30	3.03
Ring Oscillator Power ( $P_{RO}$ , $\mu\text{W}$ )	193	142
Estimated Channel Power at 100 kcps ( $\mu\text{W}$ )	110	47
Estimated Channel Power at 100 Mcps ( $\mu\text{W}$ )	632	492

Table 2: TDC channel power for count rates of 100 kcps and 100 Mcps, assuming  $t_{RO} = 10\text{ns}$

### 198 3.6. Summary of Figures of Merit

199 The figures of merit of the TDC design are presented in Figure 8. The figures in the table are calculated  
 200 by setting the TDC tuning voltages to their nominal settings, and conservatively assuming an input count

201 rate of 100 Mcps and  $t_{RO} = 10\text{ns}$ . In reality, the TDC's power and resolution are highly dependent on count  
 202 rate and tuning voltages as detailed in the previous sections. The range of our TDC is practically limited  
 203 by the accumulation of jitter on the ring oscillator; given a maximum jitter specification for the TDC, the  
 204 maximum allowable range is the  $T_{in}$  value which corresponds to that level of jitter in Figure 6. To avoid  
 205 making an arbitrary assumption about required jitter, we do not report a single range value in this table.

	2019 TCASI	2019 JSSC	2023 JSSC	2014 JSSC	2018 JSSC	This Work	
Architecture	Nutt+Cyclic Interpolator	Dynamic Reallocation + dual clock	GRO + Cont. Counter	Pipeline	RNS	Ring Oscillator + Vernier TDC	
Technology (nm)	350	180	180	65	45	22 FDSOI	
Resolution (ps)	19.5	48.8	100	1.12	9.4	295K 6.20	8.5K 8.52
TDC Area (mm <sup>2</sup> )	0.03	0.025	-	0.14	0.08	0.003	
TDC Power (mW)	2.04	2.9	0.5	15.4	24.2	295K 0.63	8.5K 0.49
Dynamic Range (ns)	640	200	96	0.578	4.6	**	
Conversion Rate (MS/s)	9.17	666	50	250	215	100	

Figure 8: Summary of figures of merit compared to other recent TDC designs.

#### 206 4. TDC Characterization Using Emulated LGAD Signals

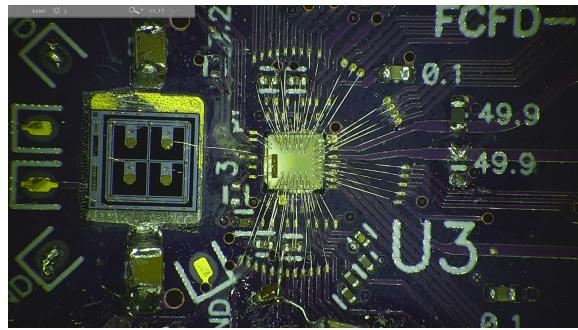
207 We characterize the performance of our TDC using emulated and realistic LGAD signals provided by the  
 208 FCFD front-end readout ASIC [14], which achieves a time resolution better than 9 ps. The FCFD ASIC  
 209 generates discriminated LGAD signal pulses using an internal charge injection circuit triggered by a 745-  
 210 OEM pulse generator. These pulses are used as inputs to the TDC ASIC for evaluation. The experimental  
 211 setup, including the readout and data acquisition systems, is described, and photographs of the test board  
 212 containing the FCFD ASIC connected to the LGAD sensor are shown in Figure 9.

213 To start, we first measure the timing jitter using signals generated by the 745-OEM pulse generator. A  
 214 schematic diagram of the pulse generator measurement setup is shown on the top right of Figure 9. The  
 215 signal waveforms for a characteristic event produced by the pulse generator that enter as input to the TDC  
 216 are shown on the left of Figure 10.

217 Next, we perform the charge injection study. The schematic diagram of the charge injection study setup  
 218 is shown on the bottom right of Figure 9. The FCFD output is used as the start signal for our TDC, while  
 219 the second output of the pulse generator is used as the stop signal. In order to ensure that the stop signal  
 220 from the pulse generator arrives later than the start signal from the FCFD output, we introduce a physical  
 221 delay using longer cables for the pulse generator output. The signal waveforms for a typical event produced  
 222 by the charge injection testing setup described above are shown on the right of Figure 10, illustrating that  
 223 the FCFD output signal is typically short with a width of 10 ns.

##### 224 4.1. Sensor Testing Results

225 We first characterize the performance of the TDC ASIC using the pulse generator, which, as discussed  
 226 in Section 4, generates both the start and stop signals. The Arduino-based readout system is used to collect  
 227 the start and stop time stamps and the elapsed time ( $\Delta t$ ) between the start and stop signals is digitized and



Pulse Generator Study



Charge Injection Study

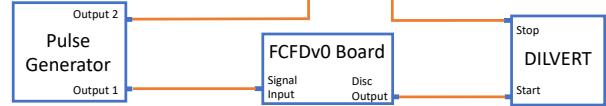


Figure 9: A photograph of the FCFD characterization board with an LGAD sensor mounted showing the FCFD wire-bonded to the readout board and to the LGAD sensor(left). On the right, schematic diagrams of the pulse generator test measurement (top-right) and the FCFD charge injection test measurement (bottom-right) are shown.

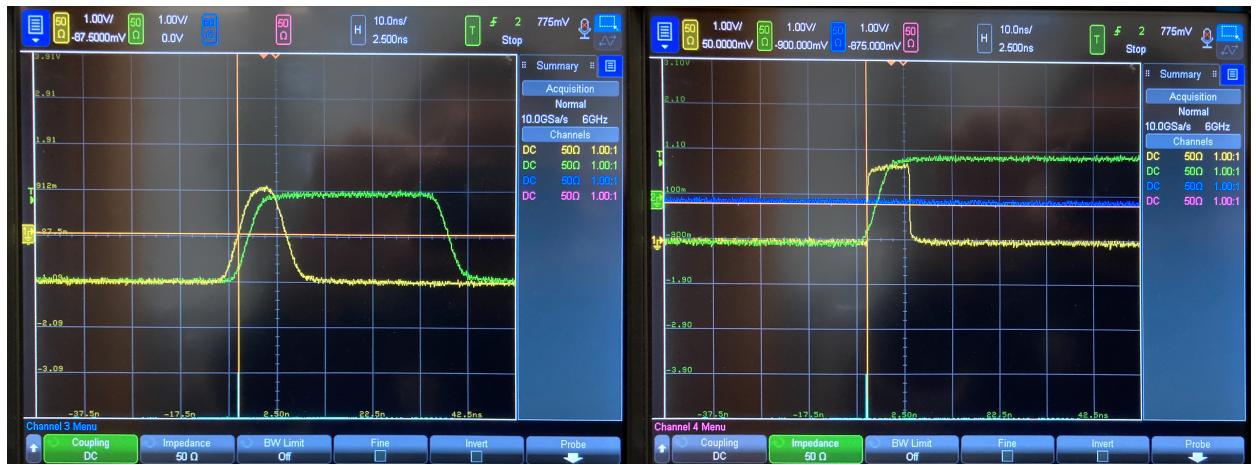


Figure 10: Waveforms of the signals tested acquired by oscilloscope. Left: waveforms for two pulse generator signals to represent the start and stop signals. Right: waveforms for the charge injection trigger (green) and FCFD response (yellow).

228 stored to file. We plot a histogram of the  $\Delta t$  distribution on the left of Figure 11, and fit the distribution  
 229 to a Gaussian function to extract its  $\sigma$  parameter as the resolution. We measure a resolution of 3.5 ps,  
 230 consistent with design expectations.

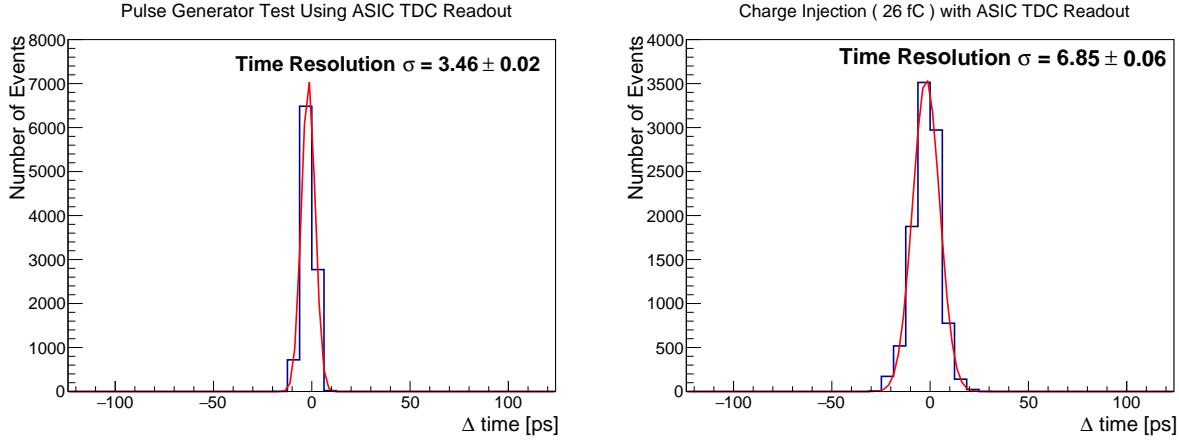


Figure 11: Histograms of the measured time difference between the start and stop signals using our TDC readout for the pulse generator test (left) and one of the charge injection measurements (right).

231 After confirming the expected performance of our TDC, we employ it to measure timestamps for realistic  
 232 signals using the internal charge injection mechanism built into the FCFD ASIC. The FCFD discriminator  
 233 output is used as the start signal and the pulse generator signal used to trigger the charge injection mechanism  
 234 is used as the stop signal. Both signals are sent to our TDC and the  $\Delta t$  values are digitized by the Arduino-  
 235 based readout system. On the right of Figure 11, we show the histogram of  $\Delta t$  values for a particular charge  
 236 injection dataset corresponding to injected signals with charge of 26 fC. The same Gaussian function fit is  
 237 performed and the time resolution is extracted as the standard deviation  $\sigma$  of the fitted Gaussian. Using the  
 238 built-in switches of the FCFD ASIC, we can measure the time resolution for various datasets corresponding  
 239 to signals with injected charge ranging from 1–30 fC. The results are shown in Figure 12 as a function of  
 240 the injected charge, and are consistent with past measurements using an oscilloscope readout [14]. These  
 241 measurements confirm that the contribution of the TDC to the time resolution of the full system is below  
 242 4 ps, achieving the original design parameters.

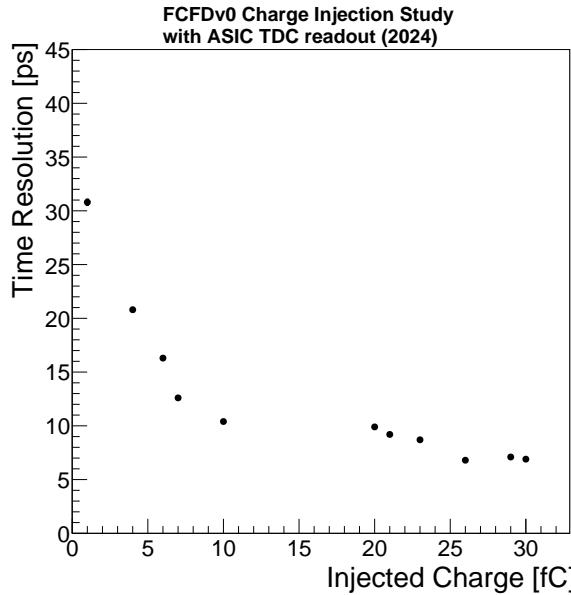


Figure 12: The measured time resolution is shown as a function of the injected charge. The internal charge injection mechanism of the FCFD ASIC is used to produce signals and the TDC ASIC is used to read out and digitize the time stamps.

## 243 5. Conclusions and Outlook

244 Development of low-power, high-resolution TDCs for applications in high precision timing is one of the key  
 245 challenges towards implementation of large-scale 4D-tracking detectors. Similarly, applications with novel  
 246 quantum sensors require very high precision TDCs that are capable of operating in ultra-cold environments.

247 In this paper we presented a novel TDC design architecture, and the characterization results of the test  
 248 ASIC in various configurations, at both room and cryogenic temperature. The design makes use of the  
 249 back-gate biasing capabilities of the GlobalFoundries 22FDX node to provide fine-tuning for the coarse and  
 250 fine TDC stages. Using the GF 22FDX node allowed us to design a low complexity, small footprint TDC  
 251 with no noise contribution from bias circuits and separate tuning voltages. Our measurements using both a  
 252 pulse generator and a dedicated LGAD front-end readout ASIC demonstrate that the compact TDC design  
 253 achieves better than 4 ps timing resolution, with a power consumption below 630 and 110  $\mu$ W at 100 and  
 254 0.1 Mcounts/second respectively.

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